### UC Berkeley Energy Use in Buildings Enabling Technologies

#### Title

Improved Vibrational Energy Scavenging - Ferroelectric Domain Configurations

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### Authors

Shafer, Padraic Yu, Pu Miller, Lindsay <u>et al.</u>

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### Improved Vibrational Energy Scavenging Ferroelectric Domain Configurations R. Ramesh Paul K. Wright

Padraic Shafer Pu Yu Lindsay Miller Nathan Emley Eli Leland Peter Minor

## Vision

Ubiquitous wireless sensor networks have extraordinary potential for use in environmental monitoring, process control and medical device applications. Realization of these networks for wide-spread market use requires that the sensor nodes be small, maintenance-free, and compatible with integrated circuit manufacturing processes. A microscale energy scavenger can harness environmental vibrations to provide a replenishable source of power for the sensor node while simultaneously reducing the volume occupied by the power generator.

Piezoelectric vibrational energy scavenging is an ideal energy source for indoor applications where solar and wind power are not available. Piezoelectric scavengers can be fabricated as MEMS devices, free from external power sources or complex three-dimensional designs that are required by electrostatic and electromagnetic vibrational scavengers.

Competing domains reduce energy conversion by charge compensation



### Methods

Piezoelectric force microscopy (PFM) is a standard technique for mapping the local piezoelectric response of a material. An ac electrical bias is applied across the film of interest, and the mechanical response is detected by a cantilevered tip in contact with the film. The amplitude of the response indicates the strength of piezoelectricity and the phase delay indicates the direction of electric polarization.



While typically performed on rigid substrates, we have been able to produce clear images even when scanning on highly compliant benders such as those used for vibrational energy scavenging.



This allows us to examine the domain configuration of the film under conditions that an operating scavenger would experience.

Ford)







# **Questions**

Vibrational energy scavengers that have been miniaturized to be compatible with silicon-based MEMS processes are significantly less efficient than their mesoscale counterparts.

#### What is causing this loss of performance?

We believe the answer lies in the nanoscale polarization domains within the active ferroelectric film.

What is the as-grown domain configuration pattern?

How does this pattern impact mechanical-electrical transduction? How can we control the domain structure to our advantage?





 $90 \oplus$  domain wall motion enhances the piezoresponse

### **Findings**

PFM images of the prototypical ferroelectric film,  $Pb(Zr,Ti)O_3$ [PZT], show that a polarized single domain state is stable when the film is grown on a similar substrate,  $SrTiO_3$  [STO], but not on silicon. Cycling the applied bias also reveals the presence of an additional stable orientation, corresponding to the preferred in-plane domains.

